



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2818  
Examiner: Chuong A. Luu  
Confirmation No.: 6341

In Re PATENT APPLICATION Of:

Applicant: Noriko Tomita et al. )  
Serial No.: 10/660,490 ) **AMENDMENT**  
Filed: September 12, 2003 ) **and**  
For: SEMICONDUCTOR SUBSTRATE ) **PETITION for extension of time**  
SURFACE PROTECTION METHOD )  
Attny Ref.: OHG 135 )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is in response to the Official Action mailed on April 11, 2005. Payment for two months' extension of time is attached. Please charge our Deposit Account No. 18-0002 if any additional fees are needed to enter this paper, and please advise us accordingly. It is noted that no petition is required because of the authorization to charge, but this paper is a petition for extension of time.

The amendment to claims 1 and 7 is supported in the specification at page 5, lines 6-22 and in the paragraph spanning pages 8-9. The phrase "subsequent step" appears in the specification at page 9, line 3. New claims 19 and 21 are supported at page 5, line 15. New claims 20 and 22 are supported at page 2, lines 1-3. New claim 23 is supported at page 2, lines 1-3; page 7, line 19; and page 9, lines 4-13. In claim 23 the word "weight" is added to the phrase "high molecular," which is supported by the word "weight" at page 6, lines 4 and 6. Claims 24 and 25 are supported at page 5, lines 24 and 26. Claims 13-18 are canceled without prejudice.

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450.00 OP

FEE ENCLOSURE: \$450 -  
Please charge any further  
fee to our Deposit Account  
No. 18-0002